



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the application of)	
)	
Topas CHANG et al.)	Group Art Unit: 2125
)	
Application No. 10/775,595)	Examiner: J. Gandhi
)	
Filed: February 9, 2004)	Attorney Docket No. MXICP016
)	
For: SYSTEM AND METHOD FOR)	Date: January 26, 2006
MONITORING WAFER FURNACE)	
PRODUCTION EFFICIENCY)	Confirmation No. 1768
)	

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on January 26, 2006.

Signed: _____

Diane Schwanbeck

AMENDMENT

Commissioner for Patents
Post Office Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Applicants submit this paper in response to the Office Action dated July 26, 2005. A response to this Office Action was due on October 26, 2005. Accordingly, Applicants are concurrently submitting a request for a three-month extension of the period for response.

Please amend this application as follows:

The **Amendments to the Specification** begin on page 2 of this paper.

The **Amendments to the Claims** made herein are reflected in the **Listing of Claims**, which begins on page 3 of this paper.

The **Amendments to the Drawings** are shown on page 6 of this paper and include four (4) sheets of replacement drawings.

Applicants' **Remarks** begin on page 7 of this paper.